

ME 411 / ME 511

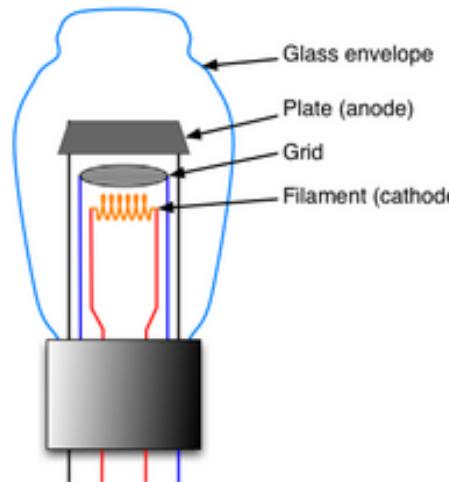
# Biological Frameworks for Engineers

ME 411 / ME 511

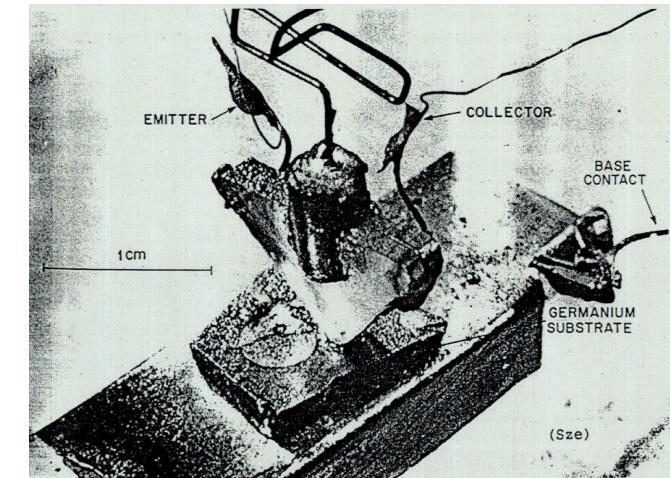
# Micro and Nano Fabrication

# In the beginning...

- Vacuum Tube

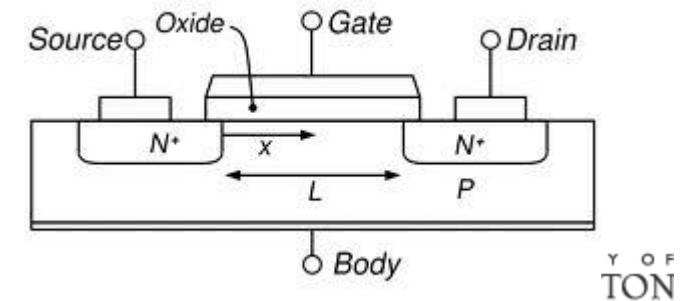


- Solid State Transistor



Bardeen & Brattain, *Phys Rev*, 74, 230 (1948)

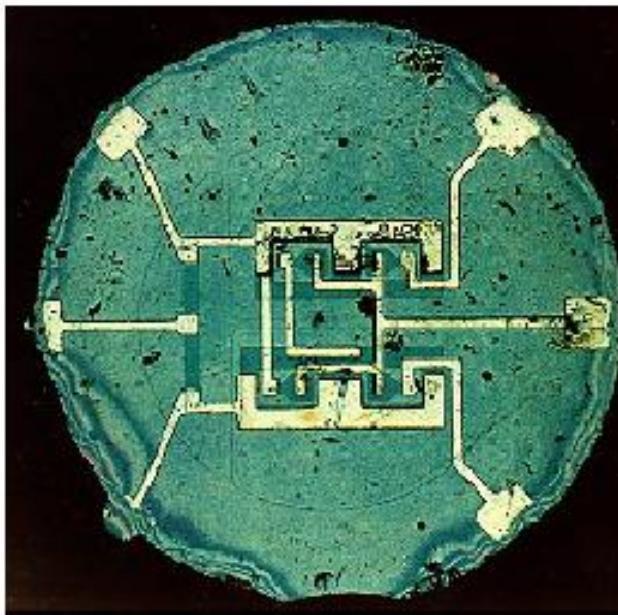
- Gate electron flow
- Warm up
- Glowed! Bugs!



T O F  
TON

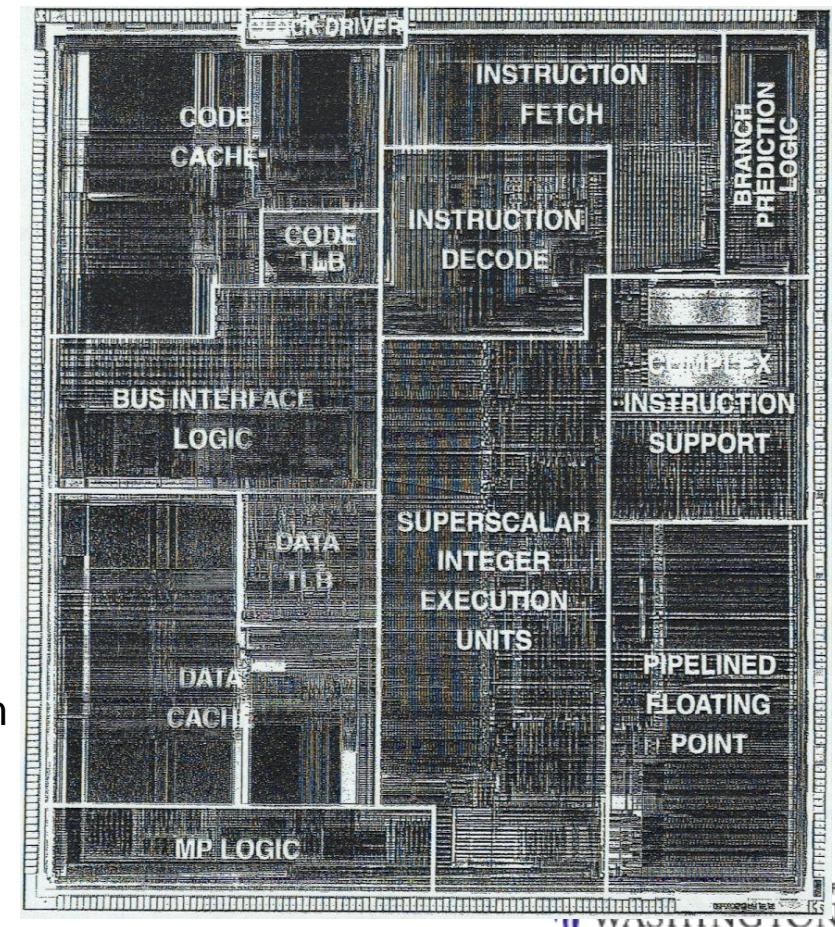
# Integrated Circuits

- Circa 1960

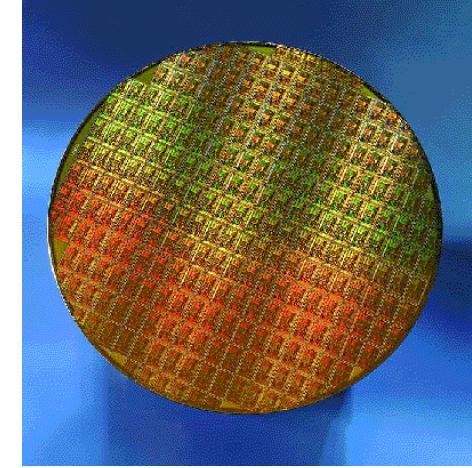
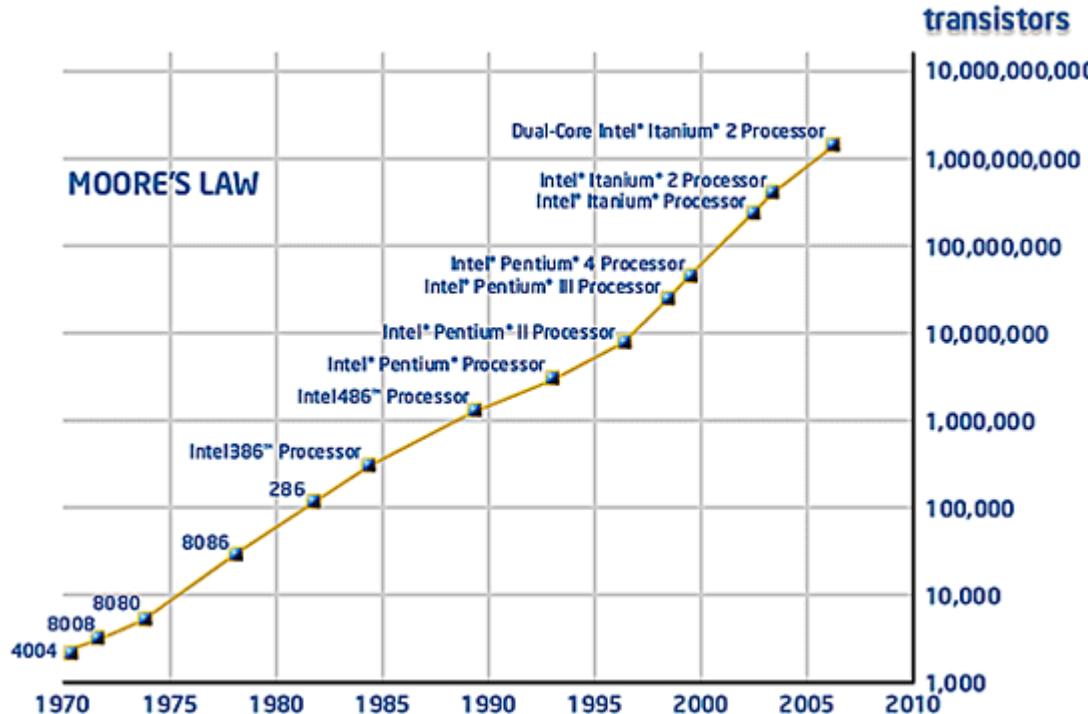


Intel 133 MHz Pentium  
3.3 million transistors  
0.35 micron Litho  
4 layer metalization

- Circa 1990



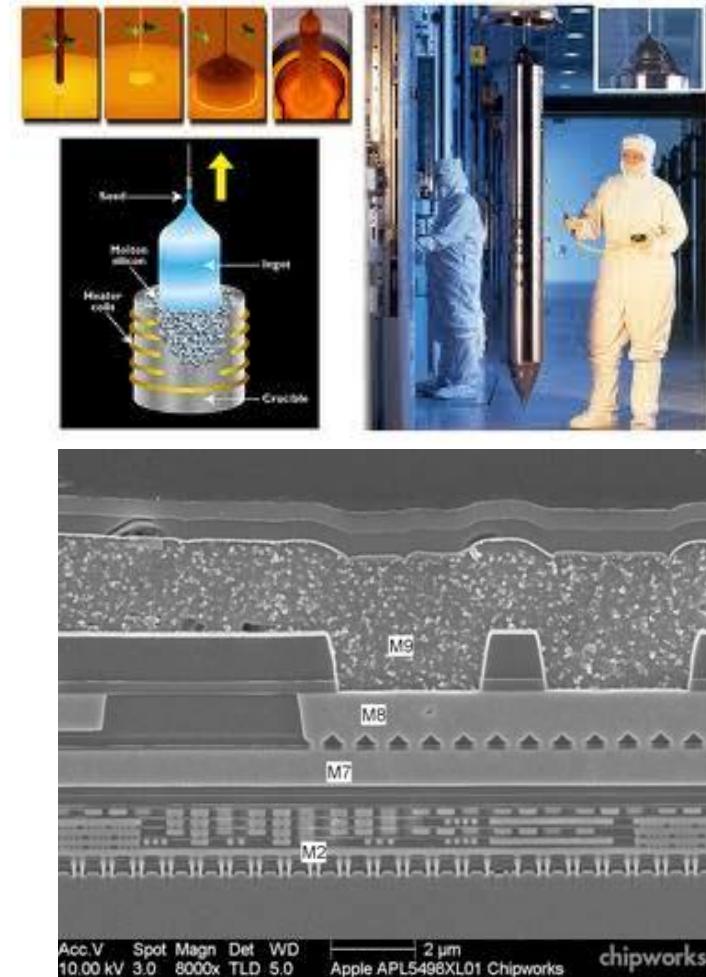
# Moore's Law



Gordon Moore, “Cramming more components onto integrated circuits”, Electronics, April 19, 1965

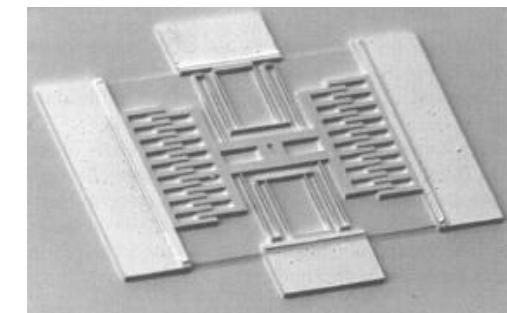
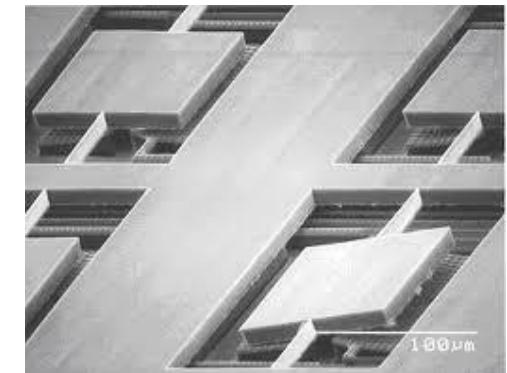
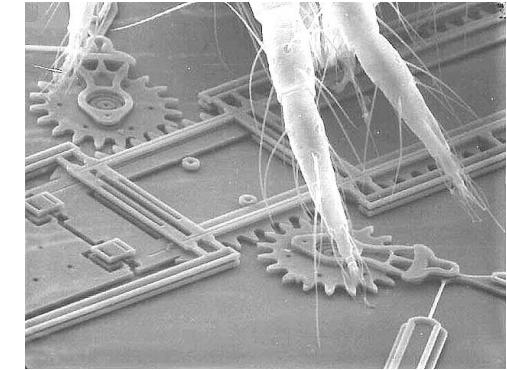
# Microelectronic Processes

- Czochralski Process
- Oxide Growth
- Lithography
- Ion Implantation
- Thin Film Deposition
  - Physical Vapor Dep. (PVD)
  - Chemical Vapor Dep. (CVD)
- Chemical Etching
  - Wet Chemical Etching
  - Dry Plasma Etching
- Chemical-Mechanical Polishing (CMP)

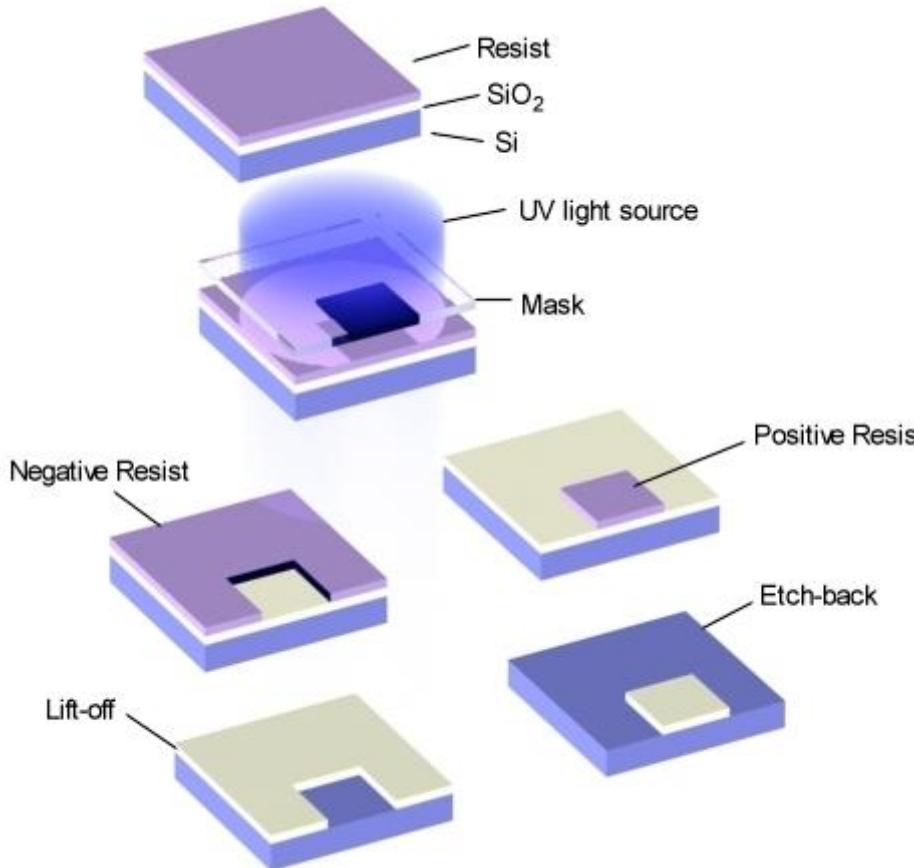


# Microfabrication

- Bulk Micromachining
  - Wet Chemical Etching
  - Plasma Etching
  - Inductively Coupled Plasma Reactive Ion Etching (ICP-RIE)
  - Deep Reactive Ion Etching (DRIE)
- Surface Micromachining
  - MEMSCAP's MUMPs Process
  - Sandia's SUMMiT Process
  - ADI's optical iMEMS Process
  - LIGA process



# Lithography



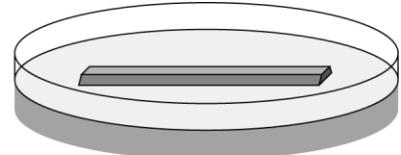
- Patterning
  - Photoresist
  - Expose
  - Develop
  - Etch!
- Positive Resist
  - Light makes it soluble in developer
- Negative Resist
  - Light causes it to polymerize and resist developer

# Soft Lithography

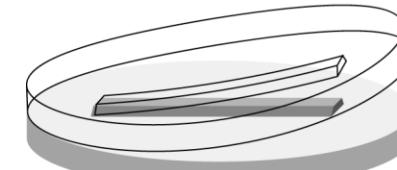
- SU-8
  - Epoxy-like negative photoresist
- PDMS
  - Glass-like silicone rubber
- Applications
  - Microcontact printing
  - Microfluidics
  - Cell-based assays



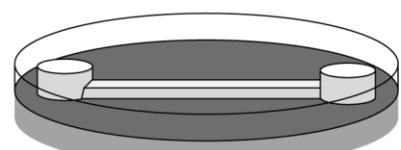
a) Fabricate master mold.



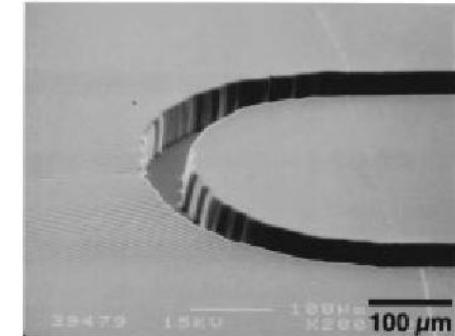
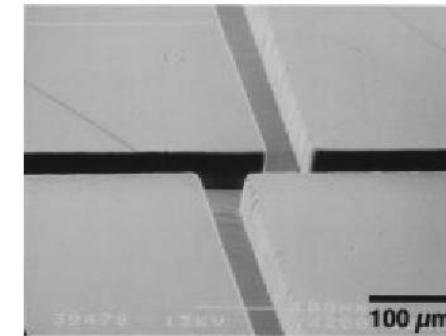
b) Pour PDMS on mold.



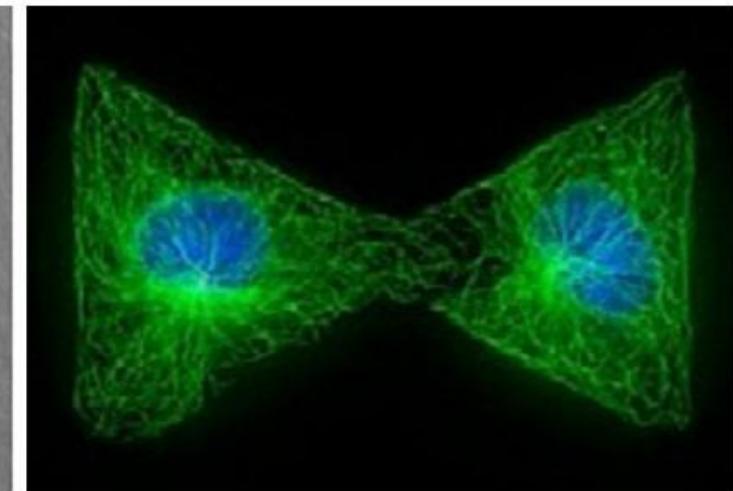
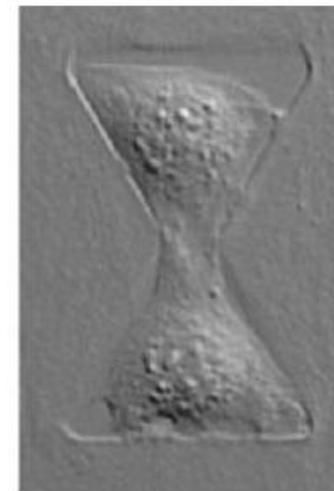
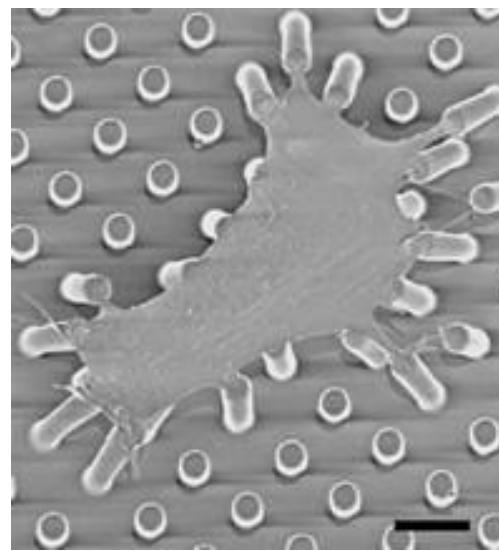
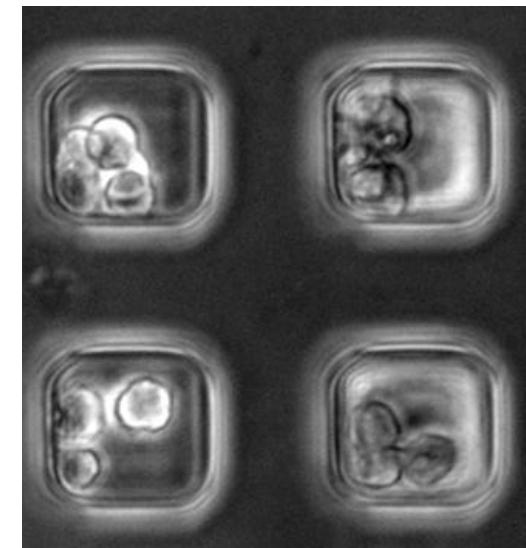
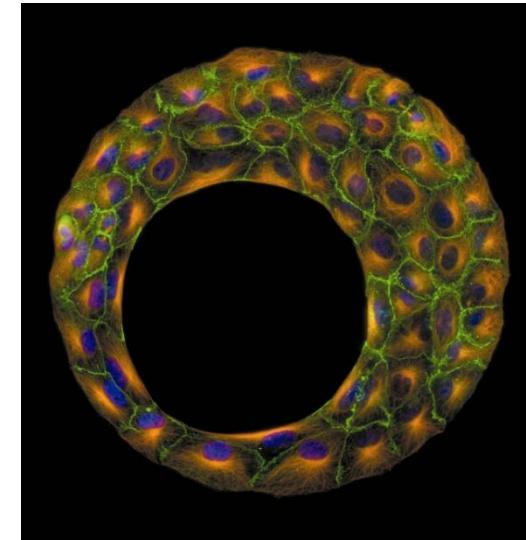
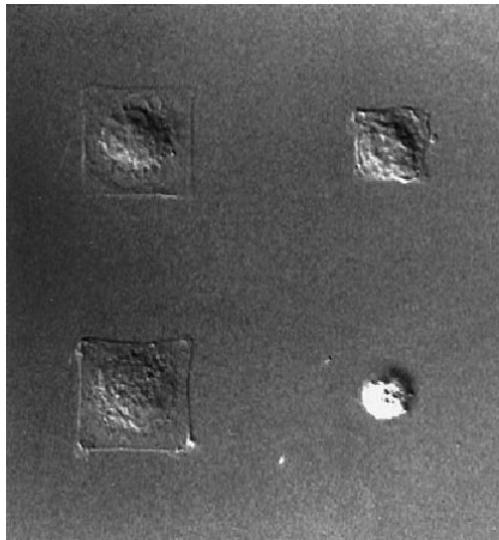
c) Cure PDMS and remove.



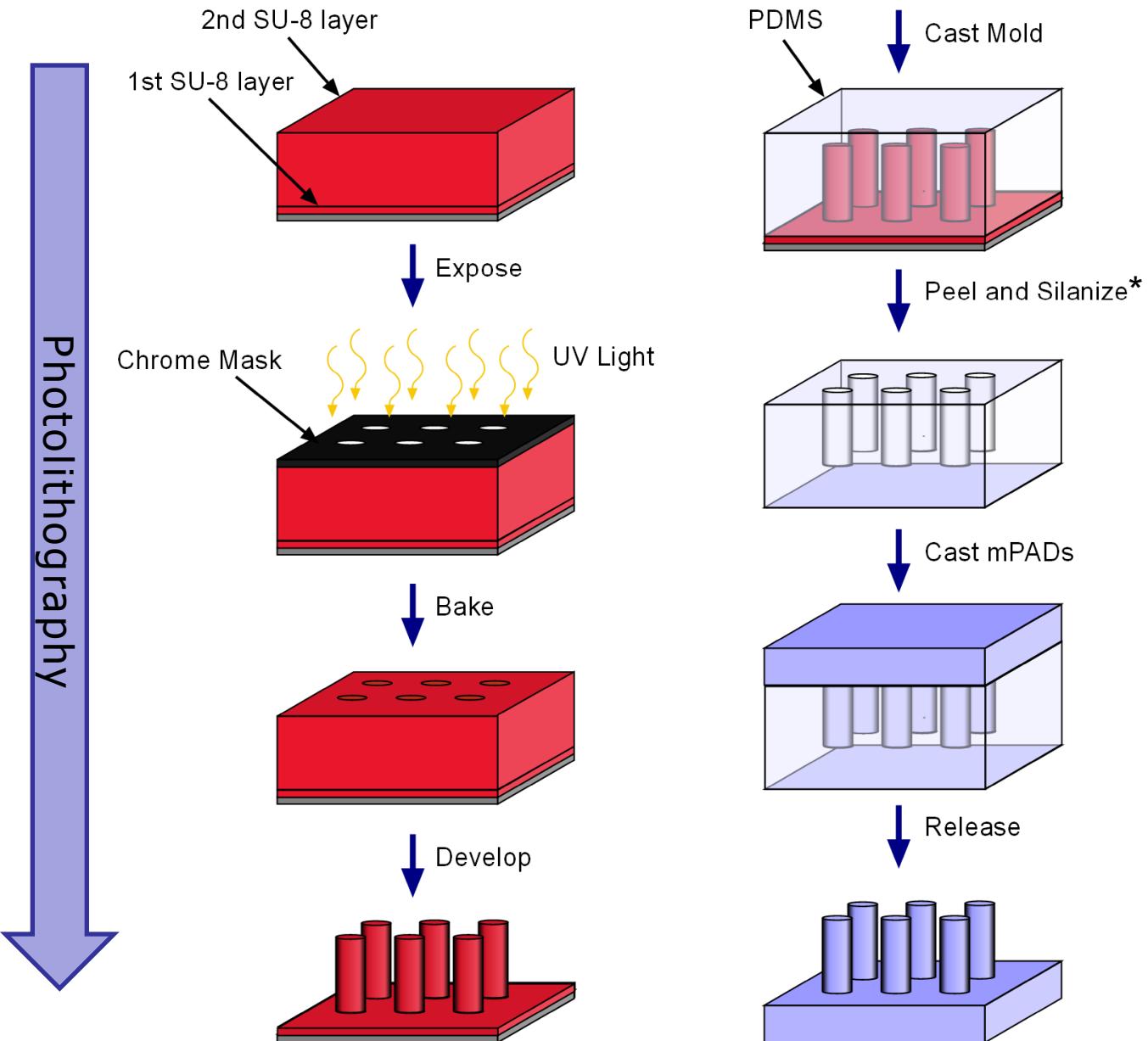
d) Punch-out reservoirs and seal onto bottom wafer.



# Tools for Cells

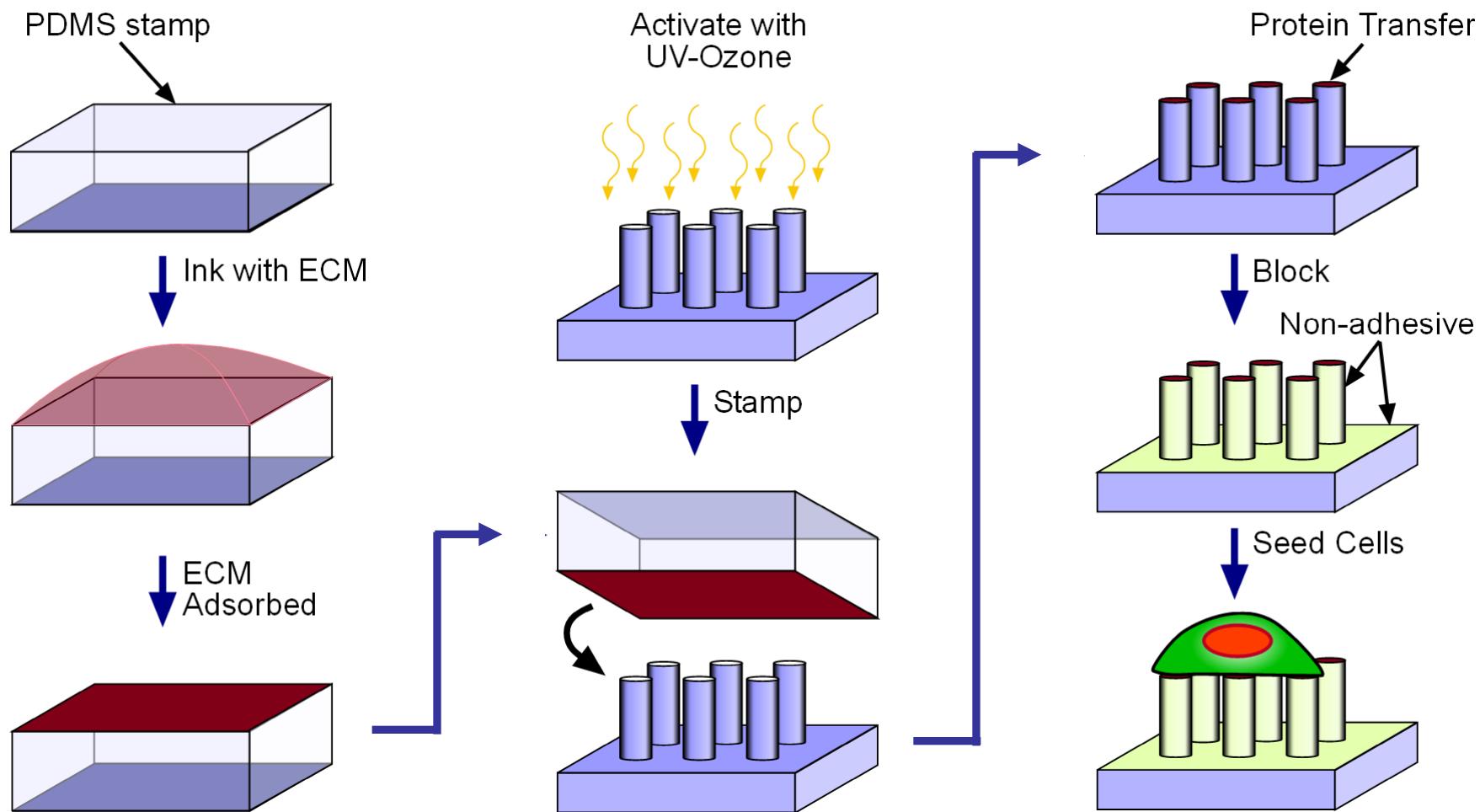


# Biological Frameworks for Engineers



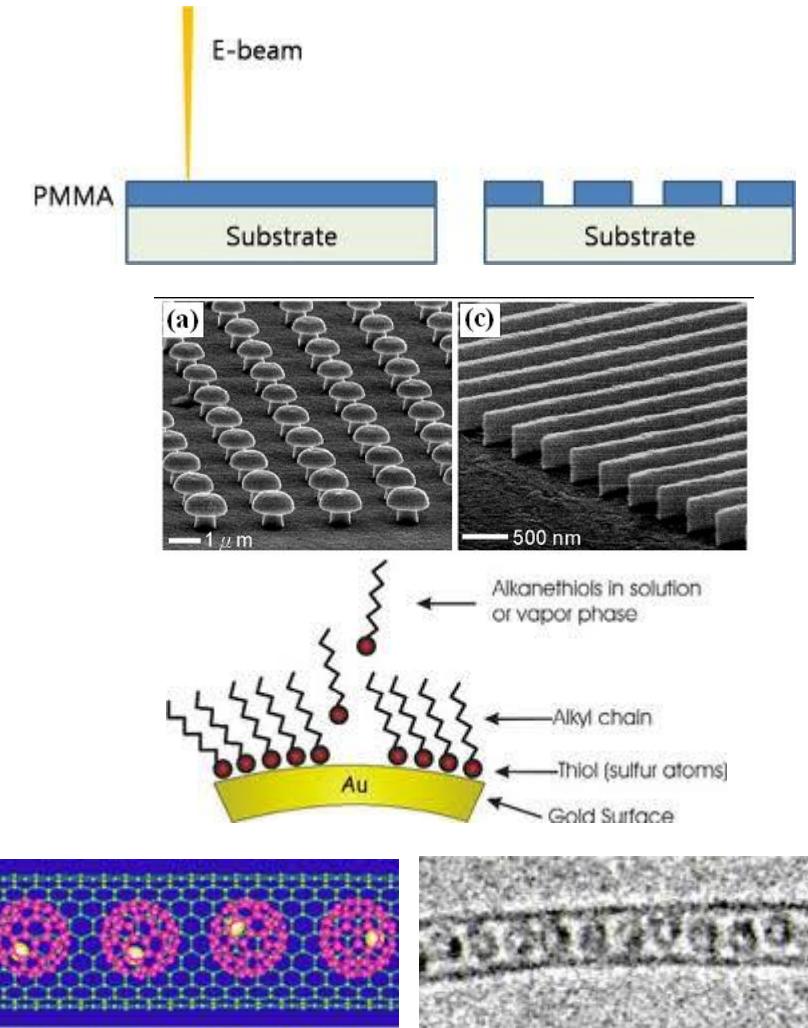
Sniadecki & Chen (2007) In *Methods in Cell Biology* - *Cell Mechanics*, Vol.83. Chapter 13:313

# Micro-contact Printing



# Nanotechnology

- Nanolithography
  - E-beam lithography
  - Nanoimprint lithography
  - Tip-based lithography
- Molecular Assembly
  - DNA origami
  - Alkanethiol monolayers
  - Supramolecular assembly
- Nanomaterials
  - Carbon nanotubes
  - Nanoparticles



# Questions?